

Vacuum Ovens

DP63C-T74

Usage: Vacuum drying of ink on Invar surface after screen printing.

- Dual-chamber structure, independent pressure control for each layer.
- Fully-automatic vacuum and air intake control.
- Equipped with a high-speed vacuum pump for rapid pressure reduction.
- Equipped with a filter to protect the vacuum pump.
- Equipped with a scanner to scan operator codes and product barcodes.
- Equipped with large capacity data storage space.

Specifications

Product name	Vacuum Ovens DP63C-T74
Pressure range	101kPa ~ 0.1kPa
Pressure drop time	≤2min (101 ~ 0.01kPa)
Pressure recovery time	≤1min (0.01kPa ~ 101kPa)
External dimensions	W1160×D1660×H1575 (excluding protrusions, excluding vacuum pump)



Forced convection

Natural convection

Fine

Options

For labware

Explosion-proof

Far infrared heating

Anaerobic

Clean

Vacuum

Semiconductor & electronics

Battery

Flat panel display

Others

Anaerobic Vacuum Drying Ovens

DP63ZC-T06

- Dual-chamber structure, independently controlled.
- Shelf heating in the chamber, with independent overheating protection device.
- Water-cooled structure inside the chamber.
- Cooling pipes integrated with hot plates, significantly improving heat exchange efficiency.
- Provide upper computer software for remote operation.
- Equipped with a scanner, can automatically call the corresponding operation program by scanning the barcode.

Specifications

Product name	Anaerobic Vacuum Drying Ovens DP63ZC-T06
Temp. control range	Room temp. +30 ~ 250°C
Heating time	Room temperature ~ 200°C ≤ 90min (unloaded)
Cooling time	200°C ~ 60°C ≤ 100min (unloaded)
Temp. adjusting accuracy	±0.5°C (at 250°C unloaded)
Temp. distribution accuracy	±10°C (at 250°C unloaded)
External dimensions	W1290×D1120×H1968 (excluding protrusions)

